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| Substitute for form 1449/PTO      |  | Application Number | 10/824/132               |   |                    |  |
| INFORMATION DISCLOSURE            |  |                    |                          | Filing Date   | 04/14/2004         |  |
| STATEMENT BY APPLICANT            |  |                    | PPLICANT                 | First Named Inventor  | YI-Nien Su et al.  |  |
|                                   |  |                    |                          | Art Unit  | 2891               |  |
| (Upp as many abasts as necessary) |  |                    | ecessery;                | Examiner Name   | Victor V. Yevsikov |  |
| Sheet                             |  | σf                 | <u> </u>                 | Attorney Docket Number  | N1085-00265        |  |

| Examiner<br>Initials* | Cite<br>No. | include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published. | T² |
|-----------------------|-------------|---|----|
| 14                    |             | A. KAJITA, et al., Highly Reliable Cultow-k Dual-Damascene Interconnect Technology with Hybrid (PAE/SiOC) Dialectrics for 65 nm-node High Performance eDRAM, Proceedings of the IEEE 2003 International Interconnect Technology Conference, June 2003           | ,- |
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| Examiner Name          | Victor V. Yevsikov   |  |
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|                       |                          | NON PATENT LITERATURE DOCUMENTS   |  |  |  |  |  |
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| 4                     |                          | A. KAJITA, et al., Highly Reliable Cu/low-k Dual-Damascene Interconnect Technology with Hybrid (PAE/SiOC) Dielectrics for 65 nm-node High Performance eDRAM, Proceedings of the IEEE 2003 International Interconnect Technology Conference, June 2003           |  |  |  |  |  |
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| Examiner  | 11110 116 | Date       | 20/25/05 |
|-----------|-----------|------------|----------|
| Signature | V Jue Voi | Considered | 09/22/05 |

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